## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art V	Unit: U	Jnassi	igned
Examiner: 1	Unassi	gned	

## In Re PATENT APPLICATION Of:

Applicant	:	Masaru TAKAISHI	)
Serial No.	:	To Be Assigned	)
Filed	:	April 28, 2006	)
International Filing	Date:	December 24, 2004	) PRELIMINARY
International Appln.	No.:	PCT/ JP04/019732	) <u>AMENDMENT</u> )
For	:	SEMICONDUCTOR DEVICE PRODUCTION METHOD AND SEMICONDUCTOR DEVICE	) ) )
Attorney Ref.	:	AI 411NP	) )April 28, 2006

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Prior to examination on the merits and to calculation of the claim fee, please amend the application as follows:

FEE ENCLOSED:\$ \$\mathcal{\Psi}\$
Please charge any further fee to our Deposit Account No. 18-0002